



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

May 26, 2026

IGI Report Number

LG802620979

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

MARQUISE BRILLIANT

Measurements

12.06 X 5.94 X 3.78 MM

GRADING RESULTS

Carat Weight

1.52 CARAT

Color Grade

G

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG802620979

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

PROPORTIONS

Medium To Slightly Thick (Faceted)

14.5%

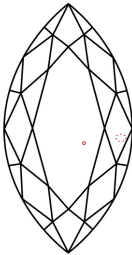
45%

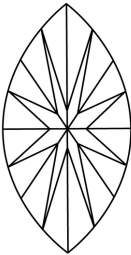
58%

63.6%

Pointed

CLARITY CHARACTERISTICS





KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

Sample Image Used



COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS ¹⁻² VS ¹⁻² SI ¹⁻² I ¹⁻³

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

LABORATORY GROWN DIAMOND REPORT



May 26, 2026

IGI Report Number

LG802620979

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

MARQUISE BRILLIANT

Measurements

12.06 X 5.94 X 3.78 MM

GRADING RESULTS

Carat Weight

1.52 CARAT

Color Grade

G

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

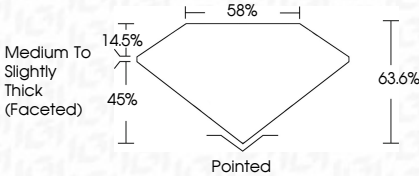
Fluorescence

NONE

Inscription(s)

 LG802620979

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa





IGI



© IGI 2020, International Gemological Institute

FD - 10 20

May 26, 2026

IGI Report No LG802620979

MARQUISE BRILLIANT

12.06 X 5.94 X 3.78 MM

Carat Weight

1.52 CARAT

Color Grade

G

Clarity Grade

VS 1

Table

63.6%

Depth

58%

Girdle

Medium to Slightly Thick (Faceted)

Culet

Pointed

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG802620979

Comments: The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa